



Sheet 1 of 2

| Form PTO-1449 (Substitute) | | U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE | | Attorney Docket Number TEGL-01168US0 | | Application/Patent Number 10/636,020 | |
|---|--|--|------------|---|-------|---|----------------|
| Information Disclosure Statement BY APPLICANT (Use several sheets if necessary) | | | | Applicant/Patent Owner Tue Nguyen | | | |
| | | | | Filing/Issue Date August 7, 2003 | | Group Art Unit 1734 | |
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| Examiner Initial | | Patent Number | Issue Date | Inventor(s) | Class | Subclass | Filing Date |
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| Examiner <i>SK</i> | | | | Date Considered 5/06 | | | |

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| Examiner <i>gc</i> | | Date Considered 5/06 | |
| <p>*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</p> <p>_____</p> <p>*1 = Copy not submitted because it was submitted in prior application SN __/____, filed _____, 20____, relied on under 35 USC §120.</p> <p>**2 = Copy not submitted because it was submitted in prior application SN __/____, filed _____, 20____, relied on under 35 USC §120.</p> | | | |